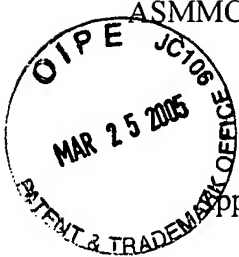


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PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Elers  
Appl. No. : 10/719,277  
Filed : November 20, 2003  
For : MULTILAYER  
METALLIZATION  
Examiner : Keisha L. Rose

Group Art Unit 2822

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to:  
Commissioner for Patents, P.O. Box 1450,  
Alexandria, VA 22313-1450, on

March 22, 2005

(Date)

*Adeel S. Akhtar*

Adeel S. Akhtar, Reg. No. 41,394

**RESPONSE TO RESTRICTION REQUIREMENT**

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In an action mailed February 22, 2005, the Examiner required restriction of prosecution to one of the following groups of claims:

Group I Claims 43-54, drawn to a semiconductor device, classified in class 257, subclass 758; and

Group II Claims 1-42, drawn to a method of making a semiconductor device, classified in class 438, subclass 118.

In response to this restriction requirement, Applicants elect to proceed, without traverse, with prosecution on the merits of Group II (Claims 1-42, drawn to a method of making a semiconductor device).

**CONCLUSION**

In view of the foregoing, Applicant submits that the application is in condition for examination on the merits, and respectfully requests the same. Please charge any additional fees,

Appl. No. : 10/719,277  
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including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: March 22, 2005

By: Adeel S. Akhtar  
Adeel S. Akhtar  
Registration No. 41,394  
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